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JUN 11 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

Applicant : Daniel G. Stearns et al.

Docket No.: CIL-10703

Serial No.: 09/669,390

Group Art Unit: 1756

Filed : September 26, 2000

Examiner: S. Rosasco

For : Repair Of Localized Defects In  
Multilayer-Coated Reticle Blanks  
For Extreme Ultraviolet Lithography

OFFICIAL

APPLICATION FOR CHANGE IN CORRESPONDENCE ADDRESS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please change the Correspondence Address for the above-identified  
application to:

John P. Wooldridge  
252 Kaipii Pl.  
Kihei, HI 96753

If you have any questions, please contact the undersigned at 808-875-0012.

Respectfully submitted,

*John P. Wooldridge*

John P. Wooldridge  
Attorney for Applicant  
Registration No. 38,725

Dated: June 11, 2004